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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Nobuyoshi YUKIHIRA, et al.  
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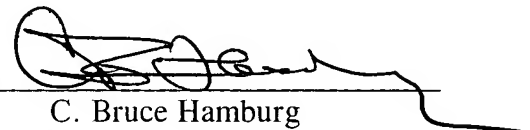
Sir:

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Respectfully submitted,

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U.S. PATENT DOCUMENTS							
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		US-					
FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Subclass	Translation
							Yes No
		JP- 61-215005	9/24/1986	JP			N <sup>F</sup>
		JP- 52-121627	10/13/1977	JP			N <sup>F</sup>
		JP- 2-78308	6/15/1990	JP			N <sup>F</sup>
		JP- 2-204005	8/14/1990	JP			N <sup>F</sup>
		JP- 50-123121	9/27/1975	JP			N <sup>F</sup>
TRANSLATION KEY: * English Abstract. <sup>F</sup> Concise statement of relevance provided in foreign search report. <sup>C</sup> Concise statement of relevance provided in specification. <sup>S</sup> Concise statement of relevance provided in IDS. <sup>P</sup> Relevant portion of reference translated. <sup>O</sup> English abstract only - copy of reference in pct search.							
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